

S/N 10/ 720,409  
confirmation no. 5057  
Applicant Feng Chen  
Response to Office Action dated 2006-09-25

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Attorney Docket: CS03-039

To: Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: William J. Stoffel 1735 Market St - Ste A455  
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Subject:

S/N 10/ 720,409  
Inventor Feng Chen  
Confirmation no. 5057  
Attorney Docket: CS03-039  
  
File date: 11/24/2003  
  
Title : **CMP Polishing Heads Retaining Ring Groove Design for Microscratch Reduction**  
  
Group Art Unit: 3723  
Examiner: Shakeri

**RESPONSE UNDER 37 CFR 1.116- EXPIDITED PROCEDURE  
- EXAM GROUP 3723-**

RESPONSE TO OFFICE ACTION DATED 2006-09-25

Dear Sir:

Enclosed is a Response to Office Action dated 2006-09-25. Please consider the following remarks:

*pls. DO NOT ENTER*  
*12/16/06*

<b>CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION</b>	
<b>Total 28 Pages in this Fax</b>	
I hereby certify that this correspondence is being :	
[ ] FAXED to the central facsimile number of patent and trademark office at the following number (571) 273-8300 or	
[ ] deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450; on the date below.	
Signature <u>William J. Stoffel/</u>	DATE <u>November 27, 2006</u>
<u>William J. Stoffel</u>	<u>Reg. No. 39,390</u> <u>Customer number 30402</u>